

Docket: 740756-2045

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Kenji ITOH et al.)
Serial No. 09/412,510) Group Art Unit: 1762
Filed: 10/05/1999) Examiner: Marianne Padget
For: PROCESS FOR TREATING A SUBSTRATE WITH A PLASMA)

REQUEST FOR ACKNOWLEDGMENT OF INFORMATION DISCLOSURE STATEMENT

Mail Stop IF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee Due form mailed June 6, 2003, acknowledging the filing of an Information Disclosure Statement on March 17, 2003.

The Notice of Allowability did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statement filed July 21, 2003. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the IDS of July 17, 2003 by providing a copy of the initialed Form PTO-1449.

If a conference would beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,

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